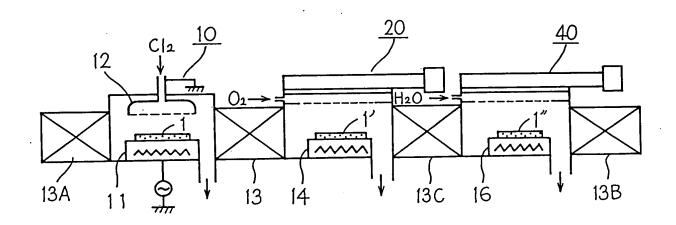
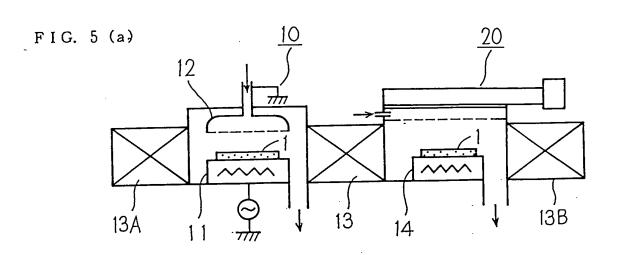


FIG. 4





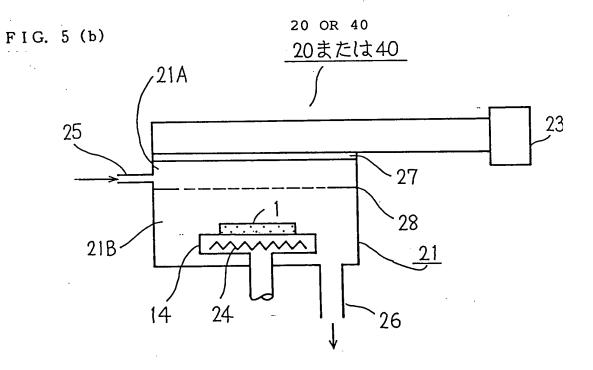


FIG. 6

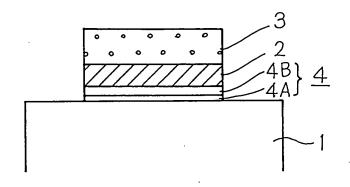


FIG. 7

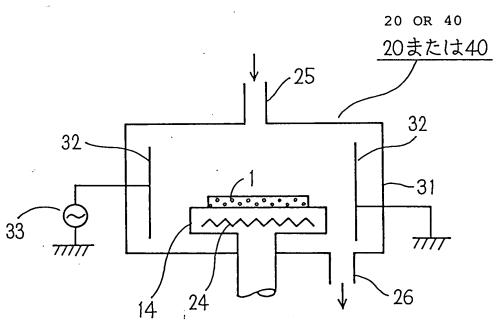


FIG. 8

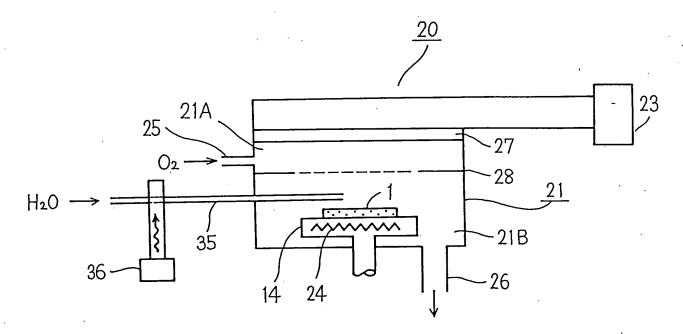


FIG. 9

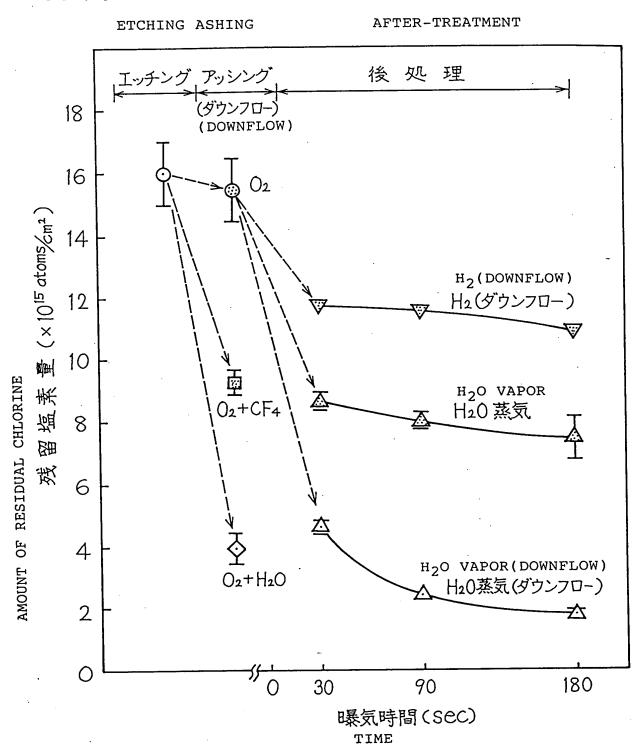


TABLE OF REFERENCE NUMERALS 参照符号・事項の一覧表

1, 1', 1"···基板, SUBSTRATE

2 · · · アルミニウム膜, ALUMINUM FILM

 $3 \cdot \cdot \cdot \neg \neg \neg \neg \neg$ MASK

4・・・バリヤメタル, BARRIER METAL

10···RIE 装置, RIE APPARATUS

11, 14···ステージ, STAGE

12, 16, 32···電極, ELECTRODE

13, 13A, 13B, 13C ・・・ロードロック室, LOAD LOCK CHAMBER

20・・・アッシング装置, ASHING APPARATUS

21, 31・・・チャンバ, CHAMBER

21A ・・・プラズマ発生室, PLASMA GENERATING CHAMBER

21B ・・・アッシング室, ASHING CHAMBER

23, 36···マイクロ波発生源, MICROWAVE GENERATION SOURCE

24···ヒータ, HEATER

25. 35・・・ガス導入管, GAS INTRODUCTION PIPE

26・・・排気管, EXHAUST PIPE

28・・・シャワーヘッド, SHOWER HEAD

33···高周波電源, HIGH FREQUENCY POWER SUPPLY

40・・・後処理装置 AFTER-TREATMENT APPARATUS